

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application)	<u>PATENT APPLICATION</u>
)	
Inventor(s): S. Brad Herner et al.)	
)	Art Unit: 1762
Application No.: 10/769,047)	
)	Examiner: Bret P. Chen
Filed: January 30, 2004)	
)	
Title: LOW-TEMPERATURE,)	<u>Customer No. 64948</u>
LOW-RESISTIVITY,)	
HEAVILY DOPED P-TYPE)	Docket No.: SAND-01138 (MA-100-I)
POLYSILICON)	
DEPOSITION)	

RESPONSE A TO OFFICE ACTION UNDER 37 C.F.R. § 1.111 TO ACCOMPANY
REQUEST FOR CONTINUED EXAMINATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicants request continued examination under 37 CFR 1.114. The amended claims and remarks included herein constitute the required submission.

AMENDMENTS to the CLAIMS begin on page 2 of this paper.

REMARKS begin on page 5 of this paper.